



Prenucleation at the liquid-Al/ α -Al₂O₃ and the liquid-Al/MgO interfaces

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ABSTRACT

Prenucleation refers to the atomic ordering in the liquid adjacent to a liquid/substrate interface above the nucleation temperature. It provides a precursor for heterogeneous nucleation in the liquid adjacent to the interface. As magnesia (MgO) and alumina (Al₂O₃) widely exist in and can be potential nucleation sites for Al-Mg based alloys, we investigate the influences of the substrate surfaces, the α -Al₂O₃{0 0 0 1} and the Al-terminated MgO{1 1 1} on the atomic ordering in the liquid Al adjacent to the liquid-Al/oxide interfaces using an *ab initio* molecular dynamics simulation technique. The study reveals the formation of an Al-layer terminating the substrates. The newly formed Al-layers display structural splitting and possess atomic vacancies, being atomically rough. Consequently, there is weak pre-nucleation at the liquid/oxide interfaces. Analysis also exposes subtle influences of the structural and chemical properties of the oxide substrates on the pre-nucleation at the interfaces. The attained information sheds light on the role of oxide particles in the solidification of Al-Mg based alloys.

1. Introduction

The classical nucleation theory (CNT) suggests that in heterogeneous nucleation a solid substrate can reduce the energy barrier to nucleate a solid phase [1–3]. Consequently, heterogeneous nucleation happens in most solidification processes, whereas homogeneous nucleation hardly occurs [1,4]. The epitaxial nucleation model [4] proposes that heterogeneous nucleation occurs in a layer-by-layer mechanism. The atomic arrangement of the substrate surface supplies a structural template for heterogeneous nucleation. The atomic ordering in the liquid adjacent to the liquid/substrate interface therefore, plays a crucial role in the heterogeneous nucleation processes [4–6]. We define this atomic ordering in the liquid adjacent to the liquid/substrate interface above the nucleation temperature as pre-nucleation [6,7]. It provides a precursor for heterogeneous nucleation of alloys.

Oxides, such as magnesia (MgO) and alumina (Al₂O₃), form during melting and liquid metal handling in the casting processes [8–15]. The oxide particles have nontrivial influences on the chemical and mechanical properties of the solidified alloys. Experiments revealed that oxide particles, including MgO and Al₂O₃, are potential nucleation sites in Al-Mg based alloys [10–15]. Moreover, oxide particles were observed to be potential nucleation sites for intermetallic compounds [16]. Therefore, knowledge about the pre-nucleation at the liquid metal/oxide interfaces is important to understand the heterogeneous nucleation processes during the solidification of Al-Mg based alloys.

The ground-state phase of alumina is α -Al₂O₃ with the mineral name corundum. Its lattice can be described in a hexagonal cell [17]. Along the [0 0 0 1] orientation of the hexagonal cell, the crystal structure consists of alternatively an O- and an Al-layer, as shown in Fig. 1a. The oxygen layer has a two dimensional (2D) close-packed hexagonal lattice. Two thirds of the octahedral sites between neighboring O layers are occupied by Al. The Al-layer is uneven and consists of 2-Al sublayers, the Al1 and the Al2 as labelled in Fig. 1a. Consequently, each Al in α -Al₂O₃ is in a distorted octahedron of O, whereas each O is in a distorted tetragon of Al (Fig. 1b).

MgO has the mineral name periclase and exhibits the salt-rock type structure with a face-centred cubic (FCC) lattice [18]. Along its [1 1 1] orientation the structure is composed of alternatively an O- and an Mg-layer (Fig. 1d). The O and the Mg layers have a 2D hexagonal lattice. The sites between neighboring O layers are fully occupied. Both Mg and O atoms are in octahedral coordination, as shown in Fig. 1c.

In common, both α -Al₂O₃{0 0 0 1} and MgO{1 1 1} contain O-layers which exhibit 2D close-packed hexagonal lattices. The major structural differences of the two oxides are the occupation ratios of the terminating sites, the smoothness of the metal layers and the coordination of O by the metals. These differences should affect the pre-nucleation at the liquid-Al/oxide interfaces.

Chemically, both Al₂O₃ and MgO are ionic compounds corresponding to the large differences in the electronegativity values between the metals (1.61 for Al, 1.31 for Mg, in Pauling scale) and O (3.44). The structure and properties of a crystal is determined by the interaction of the valence electrons of the elements in the crystal. Electronic structure

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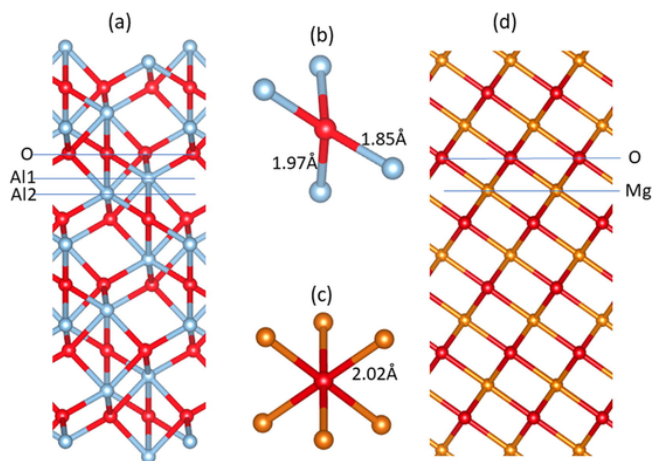


Fig. 1. Schematic structures of α - Al_2O_3 along the $[0\ 0\ 0\ 1]$ orientation (a) and of MgO along its $[1\ 1\ 1]$ orientation (d), respectively. Fig. 1b and c display the coordination of O in α - Al_2O_3 and MgO, respectively. The silvery spheres represent Al, the golden Mg and the red O. The labels Al1, Al2 in (1a), Mg (1b), and O (1a and 1b) represent the Al sublayers, the Mg and O layer in the structure, respectively. The Al-O and Mg-O bond-lengths are shown in 1b and 1c, respectively. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

theory provided that both the valence bands and lower parts of the conduction bands of MgO and α - Al_2O_3 are dominated by the O 2p and O 3s states, respectively, which suggests that the structures of these ionic oxides are determined mainly by the O sub-lattices [19,20]. Therefore, it is rational to consider the dense O-layer in both oxides as the termination layer. These surfaces of the ionic crystals, e.g. the O-terminated α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ and MgO $\{1\ 1\ 1\}$ substrates contain net charges, being polar and are therefore, unstable at ambient conditions [21,22]. However, this issue can be different when a polar surface is in a condensed metallic condition, whereby the free electrons of metals can compensate the net charges at the substrate surface [23].

Both experimental and theoretical efforts have been committed to obtain information about the atomic ordering in the liquid adjacent to the metal/oxide interfaces [8–15,24–35]. Early works focused on absorption of metallic metals including aluminium on MgO and α - Al_2O_3 surfaces [28,36], on wetting and de-wetting of aluminium on the oxide surface [29,30] and on the orientation relationship of Al/ α - Al_2O_3 [33–35]. Using the high resolution transmission electron microscopy (HR-TEM), Medlin *et al* observed a sharp interface with the orientation relationship, α -Al $\{1\ 1\ 1\}$ / α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ [34]. Recently, experiments were performed to investigate layering in the liquid adjacent to the interfaces between liquid Al and α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ using different techniques [24–27]. Using X-ray scattering method, Oh and co-workers observed pronounced layering in the liquid Al adjacent to the α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ substrate [24]. Ma, et al. employed the X-ray crystal truncation rod approach and found only two Al-layers in the liquid adjacent to the L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ interface [27]. Overall, experimental observations provided different content of layering in the liquid at the interface [24–27]. This is due to the different techniques, the experimental conditions and the experimental difficulties that liquid aluminium is chemically active to e.g. oxygen, carbon oxides, and water molecules, which always exist in reaction chambers. In this aspect, theoretical approaches can be helpful. Semiempirical atomistic molecular dynamics simulations were utilized to investigate the atomic ordering at solid/liquid interfaces [5,6,37], the influence of lattice misfits of substrates on the atomic ordering in the liquid adjacent to the interfaces [5,6], as well as the impact of atomically rough substrate surfaces on the atomic ordering in the liquid [38]. Parameter-free *ab initio* molecular dynamics (AIMD) technique was applied to investigate the effect of substrate chemistry on the prenucleation at the liquid/solid interfaces [7]. The AIMD technique was also used to investigate the

prenucleation at the L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ interfaces [24,27], and at the L-Mg/MgO interfaces [23].

In this paper, we investigate the prenucleation at the liquid-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ and liquid-Al/MgO $\{1\ 1\ 1\}$ interfaces in a comparative way. The simulations unveil subtle influence of the substrate structures and chemical nature on the prenucleation at the two interfaces. This study provides insight into the heterogeneous nucleation of Al-Mg based alloys.

2. Methods

2.1. Supercells for AIMD simulations

All *ab initio* molecular dynamics simulations were performed at temperature above the liquidus of Al. Thermal expansions of Al and the oxides were therefore, taken into account [17,18,39]. We built systems with different substrate surfaces (Table 1). For the L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ systems, the built supercells are hexagonal with the in-plane parameter, $a \approx 3a_0 = 14.40\ \text{\AA}$ (a_0 is the in-plane lattice parameter of α - Al_2O_3 at the simulation temperature [17]). The labels 1Al and 2Al represent the number of Al sublayers (Fig. 1a and the Remarks in Table 1) in the terminating Al-layer. Table 1 also includes the configurations for the L-Al/MgO $\{1\ 1\ 1\}_O$ system, which has a hexagonal supercell with $a \approx 3.615a_0 = 14.91\ \text{\AA}$ (a_0 is the lattice parameter of the fcc MgO [18]) and $c = 48.50\ \text{\AA}$. This supercell contains 450 Al in the liquid and 1000 and 75 Mg in the substrate (Table 1). This variety of supercell sizes and the substrate terminations is useful to attain statistically meaningful results, and to avoid possible results from a single starting configuration [40,41]. The large supercells are required for avoiding risk of artificial crystallization of the liquid Al.

2.2. Computational settings

We utilize the first-principles code VASP (Vienna *Ab initio* Simulation Package). It is based on a pseudo-potential plane-wave approach within the density-functional theory (DFT) [42,43]. VASP employs the projector augmented-wave (PAW) method [44,45]. Moreover, it allows variable fractional occupation numbers and therefore, works well for the insulating/metallic systems [42]. This AIMD simulation technique uses the finite-temperature density functional theory of the one-electron states, and the Nosé dynamics for generating a canonical NVT ensemble [42]. The used exchange and correlation terms are described within the generalized gradient approximation (GGA-PBE) [46]. The atomic electronic configurations in the pseudo-potentials are Mg ([Ne] $3s^23p^0$), Al ([Ne] $3s^23p^1$) and O ([He] $2s^22p^4$). We utilized the cut-off

Table 1

The L-Al/oxide interfaces built for the AIMD simulations. All the lattices are hexagonal. The subscript 1Al means only 1-Al (Al1 in Fig. 1) sublayer and 2Al sublayers (Al1 and Al2) terminating the α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}$ substrate.

Systems	Lattice parameters(\AA)	Numbers of atoms	Remarks on substrate
L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}_{1\text{Al}}$	$a = 14.40$, $c = 55.31$	Substrate: 810, 54 Al Liquid Al: 504	1-Al (Al1) sublayer termination
L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}_{2\text{Al}}$	$a = 14.40$, $c = 53.57$	Substrate: 810, 73 Liquid Al: 468	2-Al (Al1 + Al2) sublayers termination
L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}_O$	$a = 14.40$, $c = 51.82$	Substrate: 810, 36 Al Liquid Al: 486	O-termination
L-Al/ α - $\text{Al}_2\text{O}_3\{0\ 0\ 0\ 1\}_{2\text{Al}}$	$a = 14.40$, $c = 40.21$	Substrate: 1080, 90 Al Liquid Al: 270	2-Al sublayers termination
L-Al/ MgO $\{1\ 1\ 1\}_O$	$a = 14.91$, $c = 48.50$	Substrate: 1000, 75 Mg Liquid Al: 425	O-termination

energies for the wave functions (400.0 eV) and for the augmentation functions (600.0 eV) for structural optimizations, respectively. The electronic wave functions were sampled on dense grids, e.g. a $24 \times 24 \times 24$ (365 *k*-points) and $16 \times 16 \times 8$ -mesh (183 *k*-points) in the irreducible Brillouin zone (BZ) of the conventional cubic cell of MgO and the hexagonal cell of α -Al₂O₃, respectively using the Monkhorst-Pack approach [47]. For the MD simulations of the large supercells, we employed a cut-off energy of 320 eV and only the Γ -point in the BZs. Our test simulations using the cut-off energies ranging from 200.0 eV to 400.0 eV demonstrated validity of the settings.

Liquid Al was first produced by equilibrating at 3000 K for 2000 steps (1.5 fs (femtoseconds) per step). Then the produced liquid Al samples were cooled to the designed temperature (1000 K). The obtained liquid Al samples and the substrates were used to build the interfaces, which are shown in Table 1. We used two approaches in simulations of the systems. One is to relax all the atoms/ions at beginning. Another way contains two steps: first step is simulating the interfaces with the O atoms in the substrates being fixed for 1000 steps or 1.5 ps (picoseconds). The second step is to simulate the systems by full relaxation of all atoms for another 4000–7000 steps. These simulations provide statistically meaning results. We also performed simulations for selected systems with the pinned O method for sake of comparison. We employed the time-averaged method for sampling the interfaces over a period of time, typically 3.0 ps to 4.5 ps to provide statistically meaningful results [40,48].

2.3. Atomic density profile and in-plane ordering parameter

To provide a quantitative description of the prenucleation at the liquid/solid interfaces we employed two parameters [5–7,12,37]. One is the atomic density profile:

$$\rho(z) = \langle N_z(t) \rangle / (L_x L_y \Delta z) \quad (1)$$

where, L_x and L_y are the in-plane x and y dimensions, respectively. z is the third perpendicular to the interface. Δz is the bin width ($= 0.2 \text{ \AA}$ in this study) and $N_z(t)$ is the number of atoms between $z - (\Delta z/2)$ and $z + (\Delta z/2)$ at time t . $\langle N_z(t) \rangle$ represents the time-averaged number of atoms of the simulation duration. The profile quantifies the layering in the liquid adjacent to the interfaces.

Another one is the in-plane order parameter, $S(z)$:

$$S(z) = \left[\sum \exp(i\mathbf{Q} \cdot \mathbf{r}_j) \right]^2 / N_z^2 \quad (2)$$

where, the summation is over all atoms within a given bin of width, $\Delta z = z - (\Delta z/2)$ and $z + (\Delta z/2)$. \mathbf{Q} is the reciprocal lattice vector, \mathbf{r}_j is the Cartesian coordinates of the j th atom, and N_z is the number of atoms in the layer. $S(z)$ assesses the atomic ordering in an individual layer.

3. Simulation results

We here present the results of first-principles structural optimizations for the elemental solid and related oxides. The calculations produced the lattice parameters, $a = 4.039 \text{ \AA}$ for the FCC α -Al (experimental value: $a = 4.049 \text{ \AA}$ [39]), and $a = 4.195 \text{ \AA}$ for the FCC MgO (experimental value: $a = 4.211 \text{ \AA}$ [18]). The calculated lattice parameters are: $a = 4.807 \text{ \AA}$, $c = 13.116 \text{ \AA}$ for the hexagonal α -Al₂O₃, which are close to experimental data: $a = 4.758 \text{ \AA}$, $c = 12.996 \text{ \AA}$ [17]. Clearly, the calculations reproduced the experimental data. This justifies our approach and the settings.

3.1. Evolutions of the interfaces with different starting configurations

We first analyse the atomic evolutions of the liquid Al adjacent to the interfaces with different starting configurations during the *ab initio* MD simulations. Here we present the atomic evolutions of liquid Al on three substrates: The O-terminated α -Al₂O₃{0 0 0 1} (L-Al/ α -Al₂O₃{0 0 0 1}_O); The α -Al₂O₃{0 0 0 1} substrate terminated by 1-Al sublayer (L-Al/ α -Al₂O₃{0 0 0 1}_{1Al}) and the α -Al₂O₃{0 0 0 1} substrate terminated by 2-Al sublayers (L-Al/ α -Al₂O₃{0 0 0 1}_{2Al}) (Table 1). Selected snapshots of the atomic evolutions during the simulations are displayed in Fig. 2. To obtain some impression about the thermal equilibrating processes, we plotted the dependence of the total valence-electron energy of the L-Al/ α -Al₂O₃{0 0 0 1}_{2Al} system during the AIMD dynamics simulations at 1000 K in Fig. 3 as an example.

The study produces two types of atomic evolutions at the interfaces: i) On the α -Al₂O₃{0 0 0 1}_O substrate (Fig. 2a), the liquid Al atoms adjacent to the substrate move quickly to the O layer, forming a new Al terminating layer. Similar behavior occurs for the liquid Al atoms adjacent to the L-Al/MgO{1 1 1}_O interface (not shown here); ii) On the α -Al₂O₃{0 0 0 1}_{1Al} substrate (Fig. 2b), the liquid Al atoms adjacent to the interfaces move to the substrates. The Al atoms from the liquid become mixed with the original Al atoms near the O atoms, forming a new Al-terminating layer. As shown in Fig. 2c, the atoms evolution of the liquid Al atoms at the L-Al/ α -Al₂O₃{0 0 0 1}_{2Al} interface is similar to the latter type. Fig. 2(iii) also shows similarity of the atomic arrangements of the liquid Al adjacent to the three substrates at the simulation time $t = 500$ fs.

Next we have a closer look at the atomic occupation of the terminating sites at the substrates. The snapshots of the terminating Al layers for the interfaces at the simulated time, $t = 0.5$ ps are displayed in Fig. 2(iv). These terminating atoms display split along the direction perpendicular to the substrate, forming uneven layers which contain vacancies. The Al occupation ratios of the terminating sites are 51.9%, 59.3%, 66.7% for the L-Al/ α -Al₂O₃{0 0 0 1}_O, L-Al/ α -Al₂O₃{0 0 0 1}_{1Al} and L-Al/ α -Al₂O₃{0 0 0 1}_{2Al} systems, respectively. The first two values are lower than that with the O-fixed system (66.7%). The simulations also showed variation of Al occupation of the sites at the termination layer on longer simulation time. For example, the Al occupation of the sites at the terminating layer in the L-Al/ α -Al₂O₃{0 0 0 1}_{2Al} decreases with time and converges to about 56%. This will be discussed in a following section.

Fig. 3 shows the behavior of the total-valence-electron (free) energy of the L-Al/ α -Al₂O₃{0 0 0 1}_{2Al} system during the AIMD simulation. The energy decreases quickly with time at beginning and reaches the equilibration value in about 1.5 ps. This indicates that the formation of an Al terminating layer to the substrates proceeds in a couple of picoseconds. This agrees with the observations that there are no significant differences for the systems with different starting configurations (Table 1) after about 1.5 ps. Therefore, we will not distinguish them in the rest of the manuscript.

In brief, after a period of evolutions (~ 1.5 ps) the resultant liquid Al/oxide interfaces from the different starting configurations become equilibrated and resulted in similar configurations. In the L-Al/ α -Al₂O₃{0 0 0 1} systems forms an Al layer terminating the substrate and therefore, and the system is renamed as L-Al/ α -Al₂O₃{0 0 0 1}_{Al}. Similarly, we denote the equilibrated liquid-Al/MgO{1 1 1} system which terminates with an Al layer, as L-Al/MgO{1 1 1}_{Al}.

3.2. Prenucleation at the liquid/oxide interfaces

Fig. 4 shows snapshots of the equilibrated L-Al/MgO{1 1 1}_{Al} (a), the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} (b) and the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} system with the O-atoms fixed (c) as a reference. Clearly, there is an Al layer

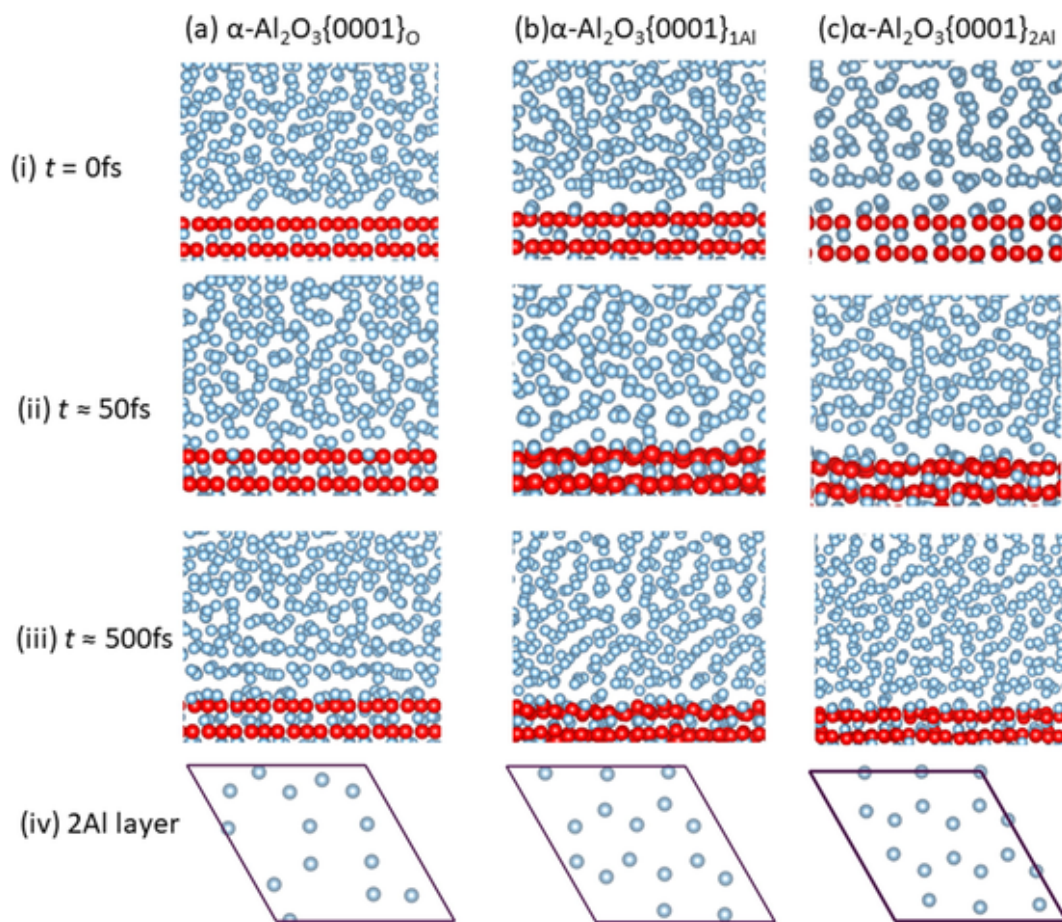


Fig. 2. Snapshots of the structural evolutions of the L-Al/ α -Al₂O₃{0 0 0 1} interfaces with different starting configurations during AIMD dynamics simulations at 1000 K. Fig. 2(iv) shows snapshots of the corresponding atomic structures of the terminating Al layers of the simulated systems at 0.5 ps. Note that the terminating Al-layers are split and uneven as shown in 2iii. The silvery spheres represent Al and red for O. The violet lines in Fig. 2iv represent the in-plane axis of the unit cells. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

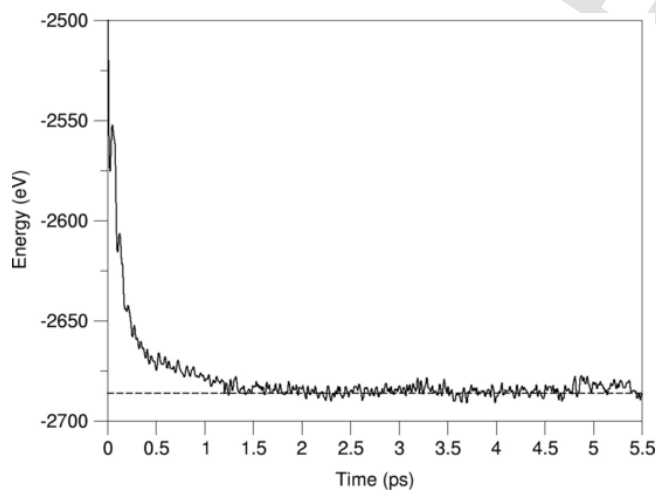


Fig. 3. Variation of the total valence-electron energy of the L-Al/ α -Al₂O₃{0 0 0 1}_{2Al} system during AIMD dynamics simulations at 1000 K. The dashed line represents the equilibrated energy of the system at 1000 K.

terminating both the α -Al₂O₃{0 0 0 1} and the MgO{1 1 1} substrates in all cases. Fig. 5 displays the atomic density profiles of the liquid Al atoms adjacent to the interfaces for the systems. The density profiles were obtained via Eq. (1) with the configurations simulated for 4.5 ps.

The frame of the density profile of the L-Al/MgO{1 1 1}_{Al} system (Fig. 5a) is similar to that of the Al₂O₃{0 0 0 1}_{Al} system (Fig. 5b). In both cases the terminating Al-layer exhibits complex structure: The Al-layer terminating the MgO{1 1 1} substrate consists of a sharp peak and a shoulder. The space between the peak and the shoulder is about 0.8 Å away (Fig. 5a). The terminating Al-layer in the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} system exhibits two clear sub-peaks with peak gap of 0.6 Å (Fig. 5b). The splitting of the terminating Al-layer is stronger in the O-fixed system (Fig. 5c).

Such splitting of the Al-terminating layer is similar to that in the bulk α -Al₂O₃ (Fig. 1a). The splitting of the terminating Al layer is demonstrated by the examples of the interfacial chemical bonding for the L-Al/MgO{1 1 1}_{Al} (Fig. 6a) and L-Al/ α -Al₂O₃{0 0 0 1}_{Al} (Fig. 6b) systems, respectively. There are more Al atoms closer to the O at the L-Al/MgO{1 1 1}_{Al} interface (Fig. 6a), corresponding to the rather sharp peak as compared with the smaller shoulder (Fig. 5a). Meanwhile, the Al atoms terminating the α -Al₂O₃{0 0 0 1} substrate display a broader range, corresponding to the broad peaks of the Al1 and Al2 sublayers as (Fig. 5b).

Here we analyse the Al occupation of the terminating sites on the substrates. Statistics analysis for the configurations over 3.0 ps provided that the Al occupation ratio of the terminating sites at the L-Al/MgO{1 1 1}_{Al} interface is 73.3%, meanwhile the Al occupation ratio at the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} interface is 55.9%. The latter number is in line with those in Fig. 2(iv). This value agrees with the recent work [27]. The Al occupation of the terminating sites at the L-Al/ α -

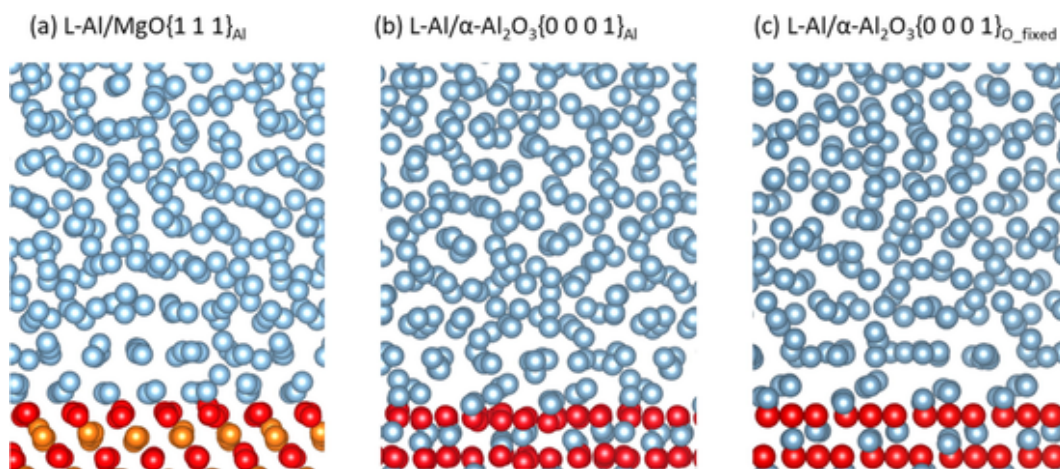


Fig. 4. Snapshots of the structures of the equilibrated L-Al/MgO{1 1 1}_{Al} (a) and L-Al/ α -Al₂O₃{0 0 1}_{Al} systems. Fig. 4c shows the snapshot of the L-Al/ α -Al₂O₃{0 0 1}_{Al} system with the O-atoms pinned. The silvery spheres represent Al, the golden Mg and the red O. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

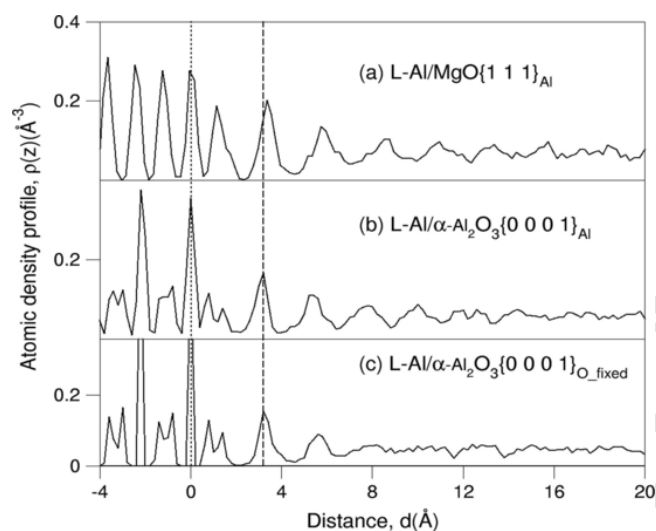


Fig. 5. Atomic density profiles of the equilibrated systems. The dotted line at 0.0 Å indicates the peak of the outmost O layer, the dashed line the 1st Al layer in the L-Al/ α -Al₂O₃{0 0 1}_{Al} systems.

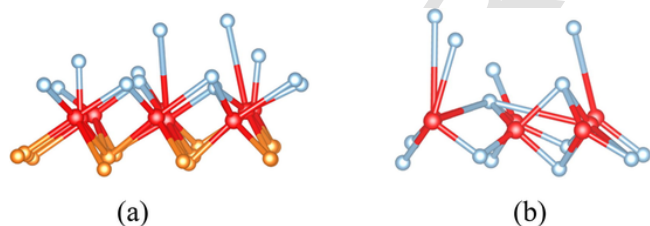


Fig. 6. Local chemical bonding at the equilibrated L-Al/MgO{1 1 1}_{Al} (a) and L-Al/ α -Al₂O₃{0 0 1}_{Al} (b) interfaces. The silvery spheres represent Al, the golden Mg and the red O. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

Al₂O₃{0 0 1}_{Al} interface with the O-layers fixed is 66.7% (Fig. 2(iv)), high than the relaxed system. This indicates importance of full-relaxation in study of liquid/solid interfaces.

Figs. 4 and 5 provide details about the layering in the liquid adjacent to the L-Al/oxide interfaces. The terminating Al-layer is well separated from the nearby liquid atoms on MgO{1 1 1}_{Al}, whereas they are admixed with each other on the α -Al₂O₃{0 0 1}_{Al} substrate. There are three/four distinct peaks in the liquid adjacent to the L-Al/

MgO{1 1 1}_{Al} and the L-Al/ α -Al₂O₃{0 0 1}_{Al} interface. The latter is similar to the recent simulations [27]. Moreover, the analysis also produced that the distance between the first Al peak and the outmost O layer in the L-Al/MgO{1 1 1}_{Al} system is slightly larger than that in the L-Al/ α -Al₂O₃{0 0 1}_{Al} system (Fig. 5). This is unexpected since the latter has a slightly shorter in-plane a - and b -axis (Table 1).

The epitaxial nucleation model indicates that the atomic arrangement of the substrate surface templates the formation of the solid at the interface [4,49]. We presented the snapshots of the important atomic layers at the interfaces in Fig. 7. To quantify the atomic ordering, we also analysed the in-plane ordering parameters for the individual atomic layers using the summed configurations of simulations for 3.0–4.5 ps via equation (2). The results were plotted in Fig. 8.

The snapshots displayed that the outmost O-layers of both interfaces are well-ordered (Fig. 7). There are atomic vacancies and displacements at both terminating Al layers. The Al atoms terminating the MgO{1 1 1} have a higher occupation than those terminating the α -Al₂O₃{0 0 1}, in agreement with our previous analysis. The 1st Al-layers exhibit vacancies and disordering.

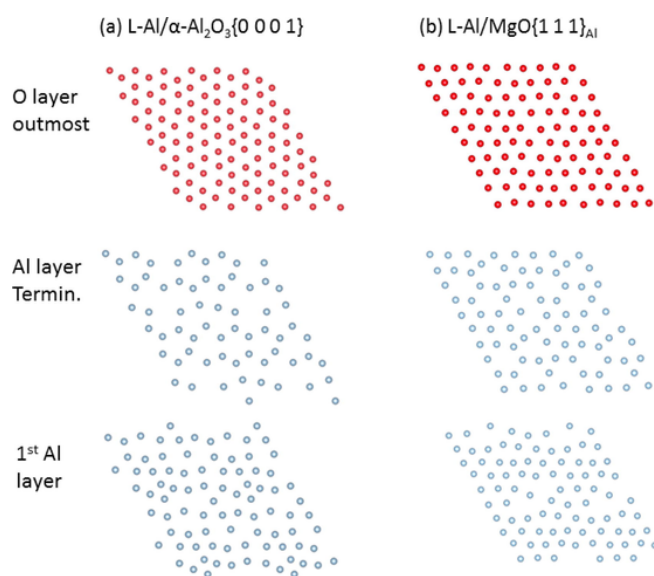


Fig. 7. Snapshots of the atomic configurations for important atomic layers in the L-Al/ α -Al₂O₃{0 0 1}_{Al} (a) and L-Al/MgO{1 1 1}_{Al} (b) systems. The silvery spheres represent Al and the red O. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

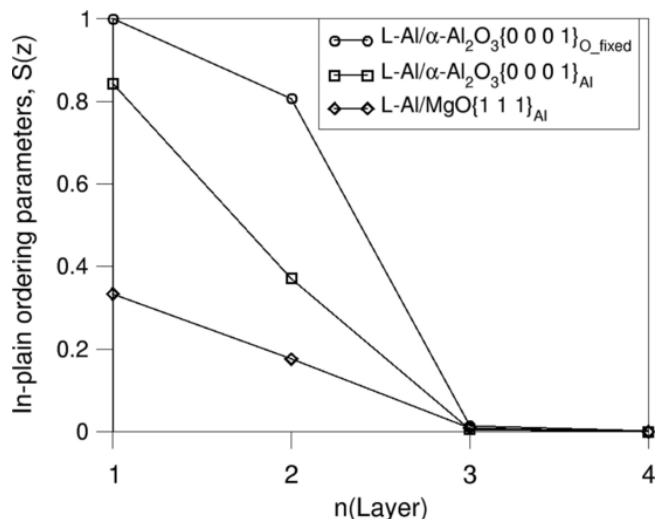


Fig. 8. In-plane ordering parameters of the equilibrated L-Al/ α -Al₂O₃{0 0 0 1} and L-Al/MgO{1 1 1}_{Al} systems at 1000 K. At the x-axis, $n = 1$ represent the outmost O-layers, $n = 2$ the terminating Al-layers, 3 the 1st Al layer and 4 the 2nd Al layers.

Fig. 8 shows the in-plane ordering parameters for the two systems. In the Al/MgO{1 1 1}_{Al} system, the in-plane ordering parameter for the O-layers in the substrate decreases quickly from bulk to the interface from 0.65 (bulk) to 0.52 (second to the surface) and 0.33 (the outmost O-layer, Fig. 8). The in-plane ordering parameter of the outmost O layer at the L-Al/Al₂O₃{0 0 0 1}_{Al} interface is 0.82 which is close to that in bulk (0.85). This corresponds to electronic band theory analysis that for these ionic crystals, the oxygen lattices determine the structures of these ionic oxides according to the electronic structure theory [19,20]. The larger $n(\text{O})/n(\text{Al})$ ratio in Al₂O₃ (2/3) than that of MgO (1/1) means higher stability of α -Al₂O₃{0 0 0 1} than MgO{1 1 1} in Al liquid.

Fig. 8 shows that the in-plane ordering decreases quickly in the liquid Al layers. The $S(z)$ values lower to about halves of those of the outmost O-layer for both fully-relaxed systems (Fig. 8). Meanwhile the small decrease of the $S(z)$ value for the terminating Al layer in the L-Al/ α -Al₂O₃{0 0 0 1} system with the substrate O fixed. This indicates the importance of relaxation of substrate atoms to describe the interfaces in a reliable way. The in-plane ordering of the 1st Al layers in all

simulated systems diminishes to nearly zero in all the simulated systems.

We also performed *ab initio* molecular dynamics simulations for liquid Al on the Mg-terminated MgO{1 1 1} substrate (L-Al/MgO{1 1 1}_{Mg}). The simulations provided a uniquely Mg termination layer. The Mg atoms at this layer are well-ordered. Meanwhile, they are partially charged. The simulations revealed that the prenucleation in the liquid Al adjacent to the L-Al/MgO{1 1 1}_{Mg} interface is higher than those at the atomically rough MgO{1 1 1}_{Al} and the α -Al₂O₃{0 0 0 1} substrates. The details of the results are out of the present scope and will be presented elsewhere.

In conclusion, at the L-Al/Al₂O₃{0 0 0 1}_{Al} and the L-Al/MgO{1 1 1}_{Al} interfaces there is an atomically rough Al layer terminating the substrates. The rough Al-layers have weak templating power and therefore, cause weak prenucleation at the liquid-Al/oxide interfaces.

3.3. Chemical bonding and interaction at the liquid/oxide interfaces

In order to get insight into the prenucleation at the L-Al/oxide interfaces, we analysed the electronic properties at the interfaces. Fig. 9 displays the iso-surfaces of the electronic density distributions at the two equilibrated systems. There are randomly distributed clouds in the liquid parts, in agreement with the free-electron picture for liquid Al. In the substrates appear regular large O spheres together with small Al and Mg spheres. This picture evidences the ionic nature of the oxide substrates. At the interfaces, there are electron clouds and Al ions in touch with the O spheres, indicating interfacial interaction.

Charges at and charge transfer between atoms provide a direct understanding of the interfacial interaction. Fig. 10 shows the charges at the atomic sites at the two studied interfaces using the Bader charge approach [50,51]. This method was implanted into the code VASP [52].

The Bader charges in the substrates are $-1.3e/\text{O}$, $+1.3/\text{Mg}$ and $+2.0/\text{Al}$, which agree with the ionic model (O^{-2} , Mg^{+2} and Al^{+3}) at first approximation. The smaller values indicate certain content of covalence [53]. The liquid Al atoms in the liquid away from the substrate surfaces are around zero, being electronically neutral.

The Bader analysis reveals that the terminating Al atoms/ions are positively charged with the value decreasing with increasing distance. Interestingly, the Al atoms at the first Al-layer at the L-Al/Al₂O₃{0 0 0 1}_{Al} lose a little electrons. This indicates interfacial interaction in this system. Meanwhile, the liquid Al atoms in the 1st Al-layer in the L-Al/MgO{1 1 1}_{Al} are neutral (Fig. 10). This explains the

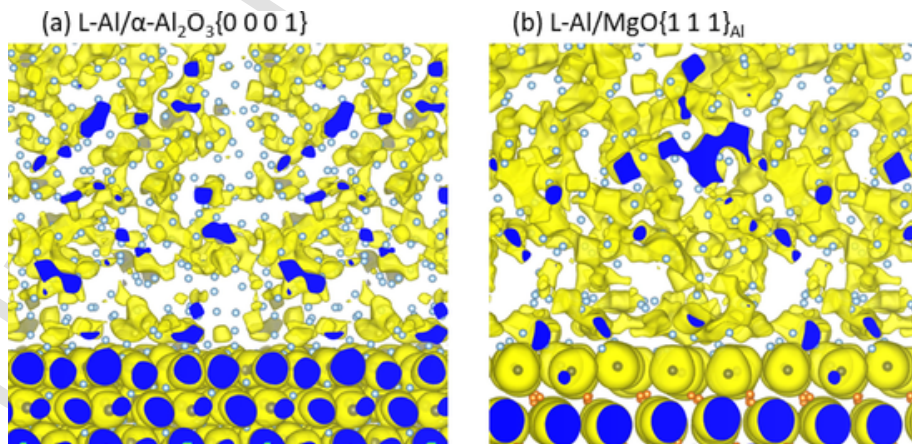


Fig. 9. Iso-surfaces of electron density at the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} and L-Al/MgO{1 1 1}_{Al} interfaces. The yellow spheres represent the iso-surfaces with electron density $\rho(r_0) = 0.037e/\text{\AA}^3$. The blue regions have higher electron densities whereas the white regions have lower values. The small golden spheres represent Mg and silver Al nuclei. The O ions (dark blue spheres) are hidden in the electron spheres. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

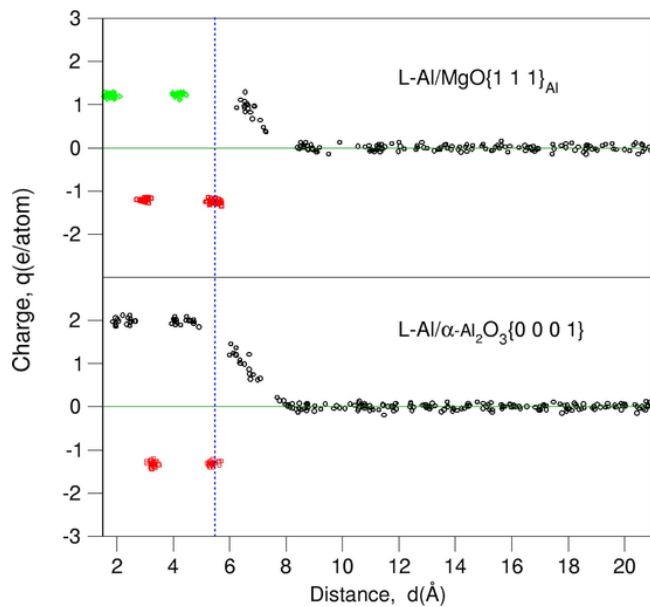


Fig. 10. The charge profiles for the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} and L-Al/MgO{1 1 1}_{Al} systems. The red squares represent charges at O, the black spheres at Al, the orange diamonds Mg. (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

smaller spacing between the substrate to the 1st Al layer in the L-Al/Al₂O₃{0 0 0 1}_{Al} system than that in the L-Al/MgO{1 1 1}_{Al} system.

4. Discussion

As mentioned before, both MgO and Al₂O₃ are ionic compounds. The outmost O-layer of both MgO{1 1 1} and α -Al₂O₃{0 0 0 1} substrates is composed of a close-packed hexagonal lattice which O atoms are partially charged ($-1e$) in the ionic model. Therefore, the substrates require the same amount of electrons from the liquid Al to reach charge balance. One would expect same occupation of the terminating sites by Al for at substrates.

The AIMD simulations provide different occupation ratios of the terminating sites: L-Al/MgO{1 1 1}_{Al} (73.3%), L-Al/Al₂O₃{0 0 0 1}_{Al} (55.9%). The smaller Al occupation ratio of the terminating sites in L-Al/Al₂O₃{0 0 0 1}_{Al} (55.9%) is compensated by the extra charge transfer from the 1st Al layer. Consequently, the atomic spacing between the 1st Al-layer to the outmost O-layer in the L-Al/Al₂O₃{0 0 0 1}_{Al} system is shorter than that in the L-Al/MgO{1 1 1}_{Al} system, though the latter has a smaller in-plane surface (Table 1).

The present AIMD simulations provided that there is a terminating Al layer on α -Al₂O₃{0 0 0 1}_{Al} or MgO{1 1 1}_{Al} in liquid Al. This Al layer is split and contains vacancies, being atomically rough. These Al atoms at the layers terminating both substrates are partially charged. The atomically rough and partially ionized Al layers hinder the prenucleation of nearby liquid Al. There are only two or three distinct Al-layers in the liquid adjacent to the interfaces. The layering is notably weaker as compared with those on a smooth metallic substrate (typically 6 layers [5–7,37]). There is also little in-plane ordering of the 1st Al-layer in both systems. Therefore, the atomic roughness of the terminating Al-layers hinders atomic ordering in the liquid adjacent to a liquid/substrate interface, in line with the recent work [38].

As mentioned before, prenucleation refers to the atomic ordering in the liquid adjacent to the liquid/substrate interface at temperatures above the nucleation temperature [6,7,49]. Therefore, the potency of a substrate for heterogeneous nucleation can be related to the degree of prenucleation [6,7,49]. Previous *ab initio* molecular dynamics simulations produced pronounced prenucleation in liquid Al adjacent to the Ti-terminated TiB₂ substrate (TiB₂{0 0 0 1}_{Ti}) [54–56]. This agrees

with experimental observations that TiB₂ particles with excess Ti are excellent grain refiners for solid Al [2,57]. Based on the results of the atomic ordering in the liquid at the interfaces, we can conclude that the nucleation potency of both MgO{1 1 1}_{Al} and Al₂O₃{0 0 0 1}_{Al} substrates to α -Al is weak.

In heterogeneous nucleation processes, a more potent substrate requires a smaller driving force (undercooling) to nucleate the metal. Therefore, for the less potent α -Al₂O₃{0 0 0 1}_{Al} and MgO{1 1 1}_{Al} substrates, the nucleation requires larger undercooling and the nucleation temperatures can even be lower than the grain-initiation temperature. As soon as the nucleation temperature is reached, nucleation occurs and grain initiation follows immediately. In such cases, nucleants of smaller sizes have the opportunity to function and the number of efficient nucleation sites should be much larger than the traditional grain-refiners which only the large particles can survive [1–3,49]. The nucleation and grain initiation processes occur almost simultaneously in an explosive way [49]. Such as explosive grain initiation produces fine grains of the solidified alloys if a large number of substrate particles were distributed homogeneously.

5. Conclusions

We investigated the prenucleation at the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} and the L-Al/MgO{1 1 1}_{Al} interfaces. Based on the simulations, the following conclusions can be attained:

- 1) At thermal equilibrium, an Al-layer forms and terminates the MgO{1 1 1} and α -Al₂O₃{0 0 0 1} substrates in liquid Al. These newly formed terminating Al-layers are split and contain atomic vacancies and displacements, being atomically rough.
- 2) There is still certain context of charge transfer occurring from the Al atoms in the 1st Al layer to the outmost O-layer in the L-Al/ α -Al₂O₃{0 0 0 1} system. This causes smaller spacing between the substrate surface and the 1st Al layer in the system.
- 3) There is weak prenucleation at the L-Al/ α -Al₂O₃{0 0 0 1}_{Al} and the L-Al/MgO{1 1 1}_{Al} interfaces. This indicates nucleation weak potency of these substrates to α -Al.

Declaration of Competing Interest

The authors declare that they have no known competing financial interests or personal relationships that could have appeared to influence the work reported in this paper.

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